



Patent  
Attorney's Docket No. 1003510-000161

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Tsutomu Saimoto et al.

Application No.: 10/506,806

Filed: September 7, 2004

For: PRESSURE SENSITIVE ADHESIVE  
FILM FOR PROTECTION OF  
SEMICONDUCTOR WAFER  
SURFACE AND METHOD OF  
PROTECTING SEMICONDUCTOR  
WAFER WITH THE PRESSURE  
SENSITIVE ADHESIVE FILM

) **MAIL STOP AF**

) Group Art Unit: 2811

) Examiner: Steven Ho Yin Loke

) Confirmation No.: 5415

*Do not enter!*

**AMENDMENT AND SUBMISSION OF TECHNICAL INFORMATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed August 9, 2006, please amend the  
above-identified application as follows:

*S. Hla*  
*11/27/06*